



B efw

Docket No.: 4733 USA/W-C/W-C/JB1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Steven Verhaverbeke et al.

Application No: 09/892,130

Filed: June 25, 2001

Examiner: Markoff, Alexander

Art Unit: 1746

For: ASSISTED RINSING IN A SINGLE
WAFER CLEANING PROCESS

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.312
(Amendment After Allowance)

Sir:

In Response to the Notice of Allowance mailed on December 3, 2004, the
Applicant respectfully requests the Examiner to enter the following amendment.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450
U.S. Patent and Trademark Office, Washington, D.C. 20231 on January 20, 2005

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Signature

Date

January 20, 2005